

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Art Unit: 2815  
Examiner: Mr. William F. Kraig

In re PATENT APPLICATION of:

Applicant : Akira TAKAHASHI )  
Serial No. : 10/798,482 )  
Filed : March 12, 2004 )  
For : DRY ETCHING METHOD FOR )  
SEMICONDUCTOR DEVICE )  
Attorney Ref. : OKI 414 )

**AMENDMENT**

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April 27, 2006

**Mail Stop AF**  
Director of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is responsive to the Office Action of November 1, 2005, the period for reply to which is being extended to expire on May 1, 2006 by a Petition filed concurrently herewith. Furthermore, a Request for Continued Examination (RCE) is being filed concurrently.

A fee of \$ 1810 is being submitted concurrently. Should this remittance be accidentally missing, however, or should any additional fees be needed, the Director may charge such fees to our Deposit Account number 18-0002.

Please amend the above-identified application as specified on the following pages, and then reconsider the application in view of the Remarks that are presented thereafter.

**FEE ENCLOSED: \$ 1810**  
Please charge any further  
fee to our Deposit Account  
No. 18-0002